

FIG. 1
(PRIOR ART)

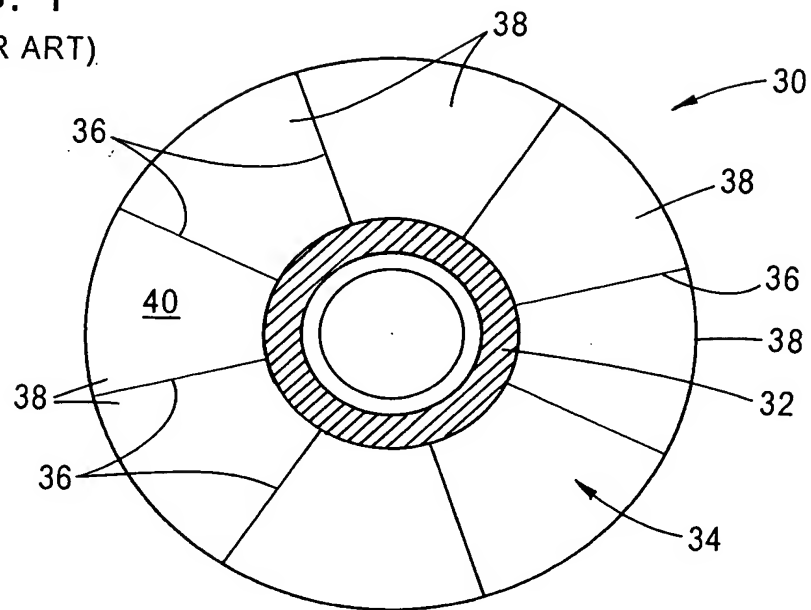


FIG. 2 (PRIOR ART)

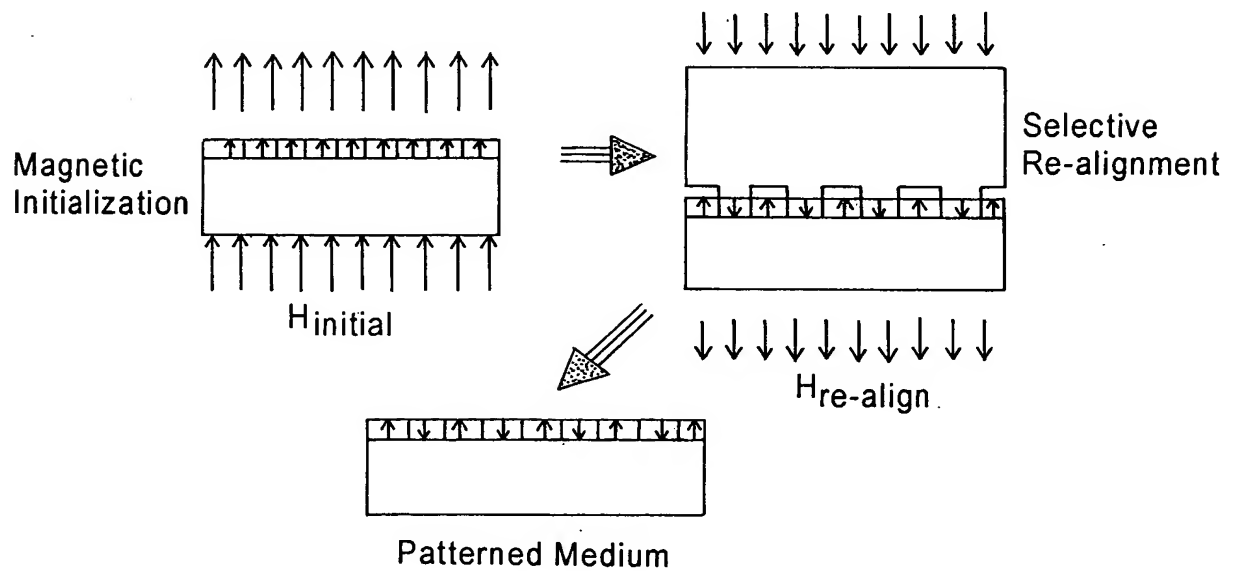


FIG. 3 (PRIOR ART)

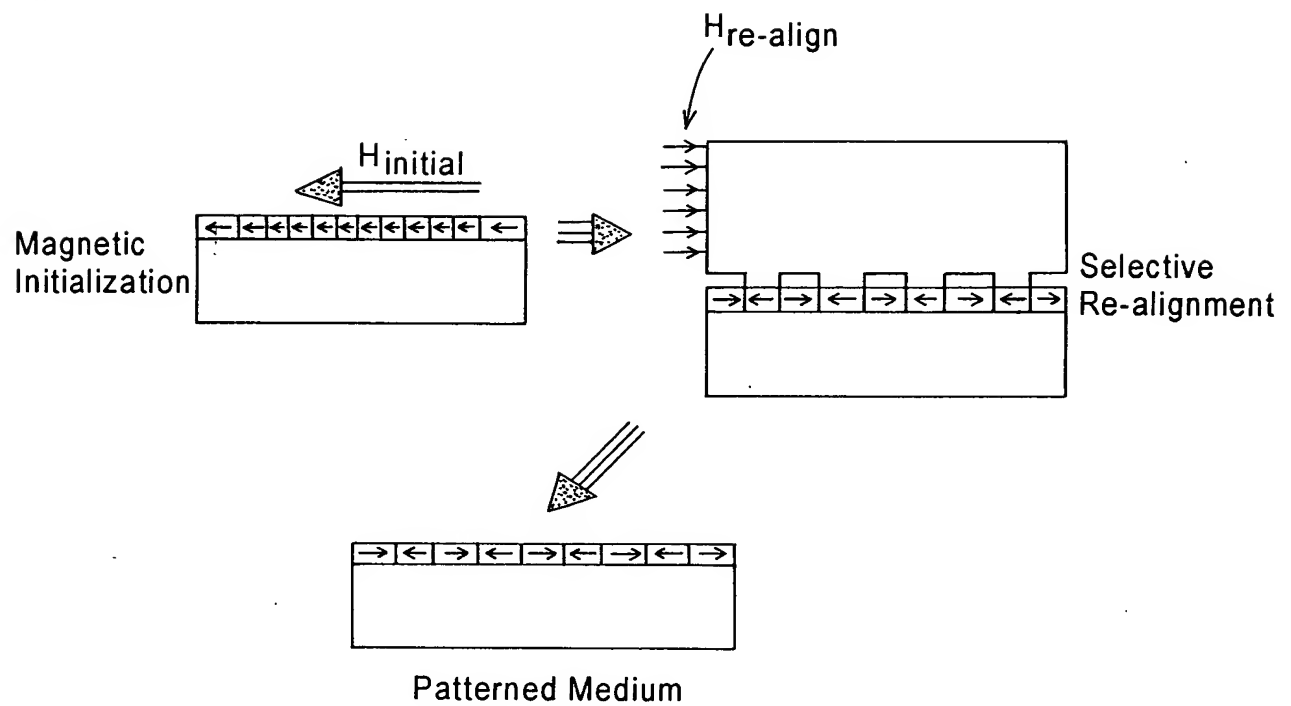


FIG. 4(A)
(PRIOR ART)

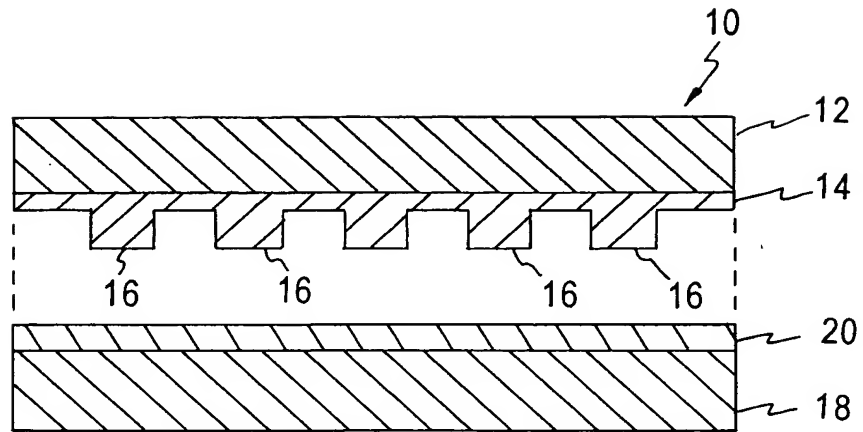


FIG. 4(B)
(PRIOR ART)

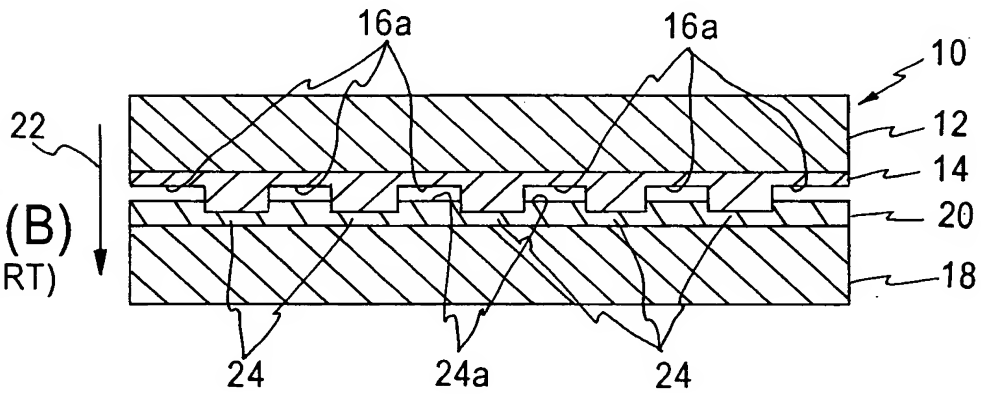


FIG. 4(C)
(PRIOR ART)

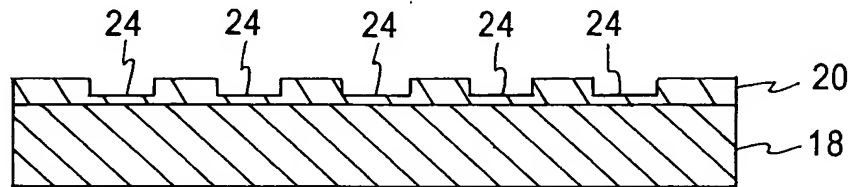
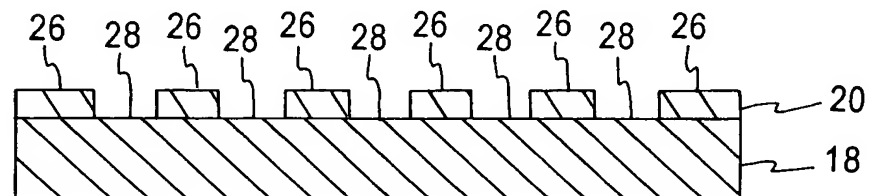


FIG. 4(D)
(PRIOR ART)



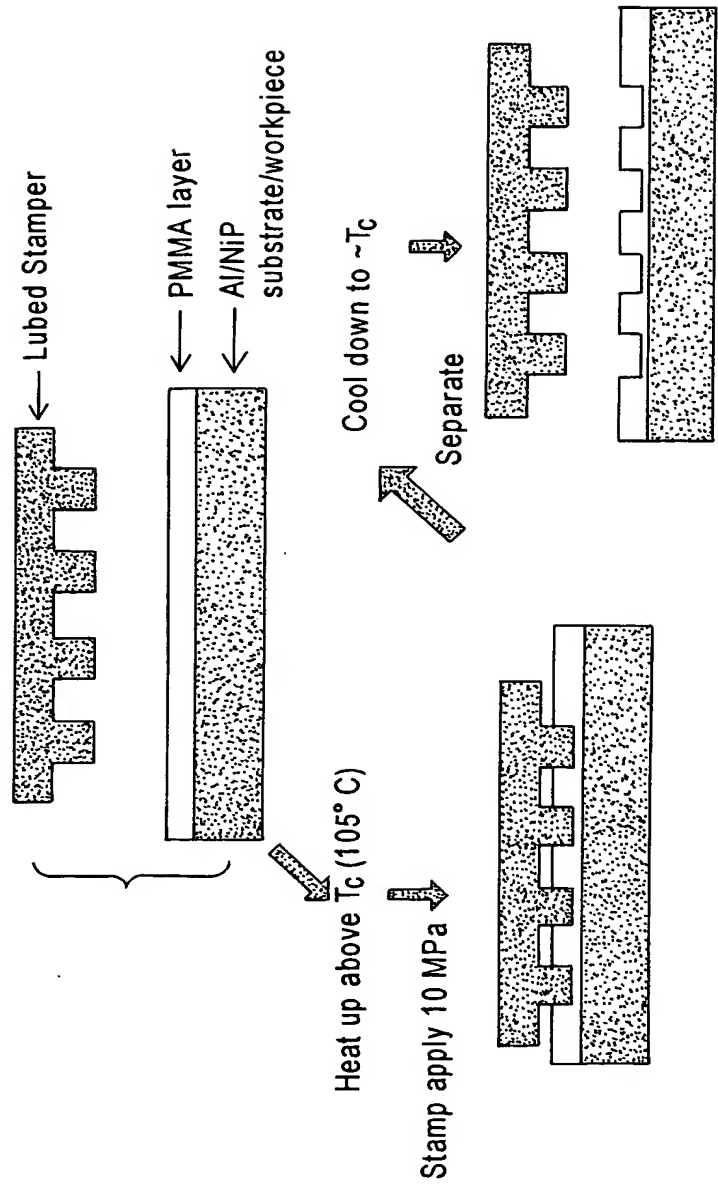


FIG. 5 (PRIOR ART)

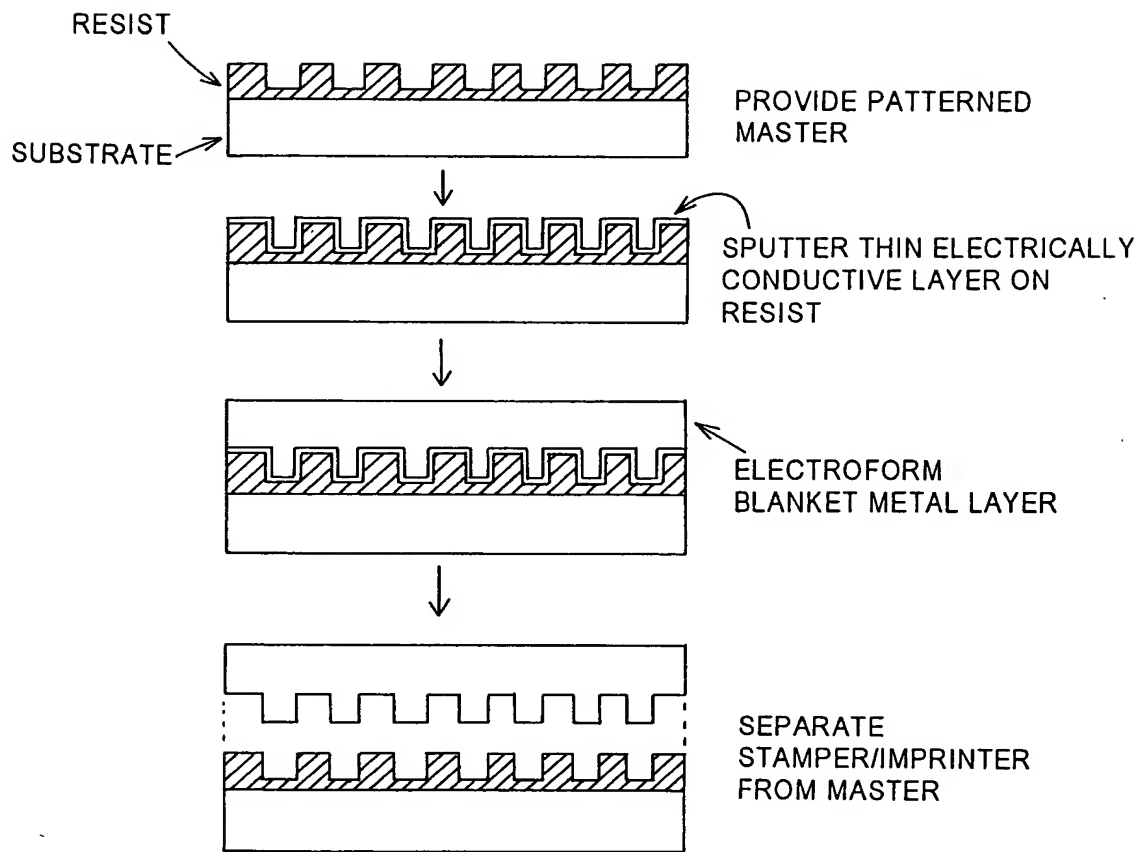


FIG. 6 (PRIOR ART)

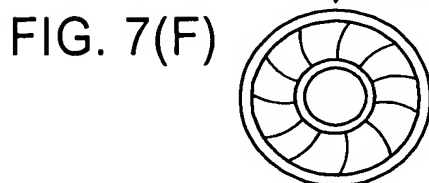
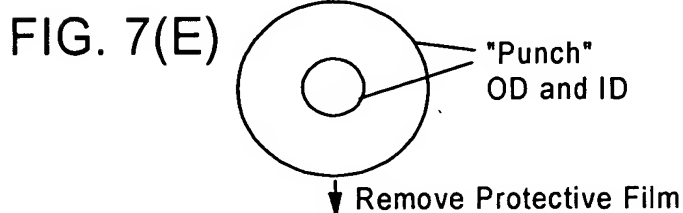
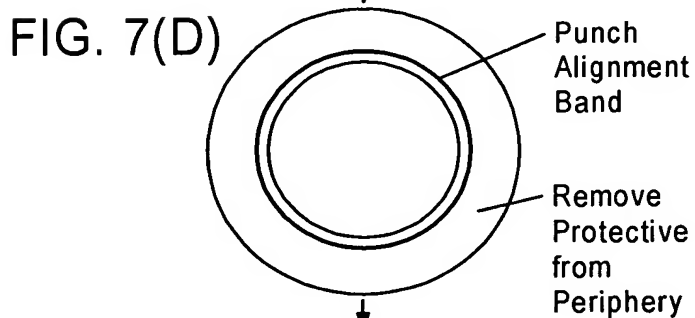
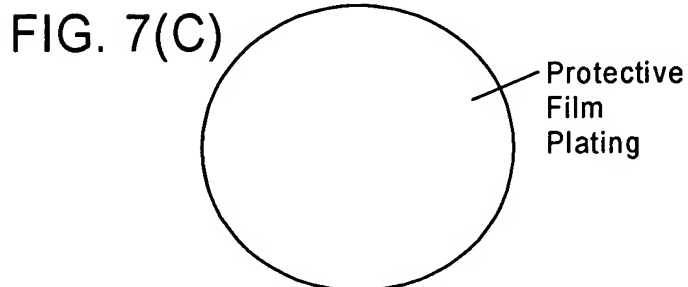
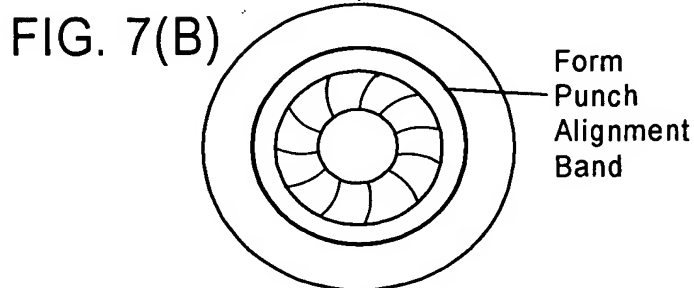
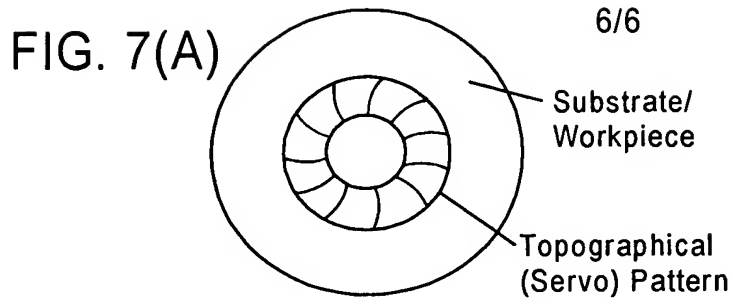


FIG. 8

801
Provide Substrate/Workpiece
with Topographical (Servo)
Pattern Formed in Central
Area of Surface

802
Form Alignment Mark (Band)
Surrounding Pattern
Periphery
Form Layer of Release
Material on Surface

803
Form Protective Film
on Surface of
Substrate/Workpiece

804
Remove Peripheral Portion
of Protective Film to
Expose Alignment Band

805
"Punch" Substrate/
Workpiece to Form Annular
Disk with Inner Diameter (ID)
and Outer Diameter (OD)

806
Remove Protective Film
to Expose Topographical
(Servo) Pattern Prior to Use